## IN THE U.S. PATENT AND TRADEMARK OFFICE

Application No.: 10/602,468

**PATENT** 

Filing Date:

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Inventor(s): Venkat SELVAMANAICKAM

SP#156/157

Group Art Unit: 1734

Examiner Name: Not Yet Assigned

Customer No.:

026304

Title: METALORGANIC CHEMICAL VAPOR

DEPOSTION (MOCVD) PROCESS AND APPARATUS TO PRODUCE MULTI-LAYER

**HIGH-TEMPERATURE** 

SUPERCONDUCTING (HTS) COATED TAPE

Mail Stop \_\_\_\_

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

## **REQUEST TO MAKE SPECIAL**

Pursuant to 37 CFR 1.102 applicants hereby request the USPTO to accelerate the processing of the above identified application for patent. The captioned application for patent relates to superconductive materials, processes and techniques for their manufacture and/or use and is within the scope of the Presidential mandate to accelerate prosecution of applications involving superconductivity.

Respectfully submitted,

By:

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